

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Confirmation No. 4123

Takeshi INAO

Date: May 10, 2007

Serial No.: 10/674,451

Group Art Unit: 3723

Filed: September 30, 2003

Examiner: Maurina T. Rachuba

For: POLISHING METHOD AND POLISHING APPARATUS USED FOR THE SAME

Via EFS -Web

Mail Stop AF

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

AMENDMENT/SUBMISSION

Sir:

This is a response to the Office Action mailed January 30, 2007 in the above-identified application. Reconsideration of the application is respectfully requested.

FEE CALCULATION

Any additional fee required has been calculated as follows:

\_\_\_\_\_ If checked, "Small Entity" status is claimed.

NO. CLAIMS			HIGHEST NO.						
AFTER			PREVIOUSLY			ADDIT.			
AMENDMENT			PAID FOR		EXTRA PRESENT		RATE		FEE
TOTAL	12	MINUS	20	* =	0	X	(\$25 SE or \$50)	\$0	
INDEP.	2	MINUS	3	** =	0	X	(\$100 SE or \$200)	\$0	
FIRST PRESENTATION OF MULTIPLE DEPENDENT CLAIM						X	(\$180 SE or \$360)	\$0	
* not less than 20 ** not less than 3								TOTAL \$ 0	